Electron-Beam Manipulation of Silicon Impurities in Single-Walled Carbon Nanotubes

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Electron-Beam Manipulation of Silicon Impurities in Single-Walled Carbon Nanotubes

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The recent discovery that impurity atoms in crystals can be manipulated with focused electron irradiation has opened novel perspectives for top-down atomic engineering. These achievements have been enabled by advances not only in electron optics and microscope stability but also in the preparation of suitable materials with impurity elements incorporated via ion and electron-beam irradiation or chemical means. Here it is shown that silicon heteroatoms introduced via plasma irradiation into the lattice of single-walled carbon nanotubes (SWCNTs) can be manipulated using a focused 55–60 keV electron probe aimed at neighboring carbon sites. Moving the silicon atom mainly along the longitudinal axis of large 2.7 nm diameter tubes, more than 90 controlled lattice jumps are recorded and the relevant displacement cross sections are estimated. Molecular dynamics simulations show that even in 2 nm diameter SWCNTs, the threshold energies for out-of-plane dynamics are different than in graphene, and depend on the orientation of the silicon-carbon bond with respect to the electron beam as well as the local bonding of the displaced carbon atom and its neighbors. Atomic-level engineering of SWCNTs where the electron wave functions are more strictly confined than in 2D materials may enable the fabrication of tunable electronic resonators and other devices.

1. Introduction

Graphene, ideally an infinite monoatomic layer of hexagonally bonded carbon atoms, is a zero bandgap semiconductor in which electrons propagate as massless Dirac fermions.[1] Single-walled carbon nanotubes (SWCNTs) can be envisioned as a cylindrically wrapped section of graphene with connected perimeters.[2]

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This structural difference confines the electron wave functions on the circumference of the tube, creating a (quasi-)1D quantum channel with a band structure dependent on the graphene cutting direction and tube diameter.[3] This 1D nature renders electronic transport in SWCNTs highly sensitive to any perturbations within or outside the structure,[4] which is useful, e.g., for chemical sensors. Their electronic transport properties can further be modified by introducing heteroatoms into the graphitic lattice.[5,6] Although typically not purposefully introduced, silicon (Si) atoms are often found as substitutional lattice impurities in graphene.[7,8] A high density of Si in both SWCNTs and graphene was recently introduced by simultaneously applying low-energy plasma and laser irradiation, and verified by atomic resolution scanning transmission electron microscopy (STEM).[9]

The effects of electron irradiation on SWCNTs have thus far been considered in the context of knock-on damage. In contrast to graphene, both the chirality and the diameter of the SWCNT have been found to influence displacement threshold energies, with smaller and more reactive tubes being easier to damage.[10] Further, the curved geometry and the orientation of each atomic site on the tube wall with respect to the electron beam direction make a full description of the scattering process significantly more complicated.[11] Finally, tight-binding methods have been used to describe knock-on damage in pristine nanotubes,[10] but they fail to provide even a qualitatively correct picture for systems with impurities.[12,13] However, besides causing damage, focused electron irradiation has recently been recognized as a tool for atom manipulation,[14–16] complementary to the established capabilities of scanning probe microscopy.[17,18] Until now, such manipulation has not been demonstrated in nanotubes.

Here, we show the possibility of moving Si impurities in SWCNTs via an out-of-plane “bond inversion” (direct exchange) process—the exchanging of places of the impurity with one carbon neighbor due to a large energy transfer from an elastically back-scattering electron[19]—similar to what was recently achieved in graphene.[15,20–23] We show that we are indeed able to manipulate them mainly along the axis of larger diameter tubes, where the atomic structure can be visualized and the local geometry resembles graphene. Using density functional theory based molecular dynamics (DFT/MD) simulations, we
further explore the energetics of various dynamic processes as a function of tube diameter and chirality.

2. Results and Discussion

For these experiments, the raw material was synthesized with a floating catalyst process yielding primarily SWCNTs with high chiral angles and a large mean diameter close to 2 nm (see the Experimental Section). The Si impurities were incorporated through the use of simultaneous plasma and laser irradiation as described in our recent work, resulting in ≈63% threefold atomic coordination (Si-C₃), as confirmed by direct imaging and electron energy loss spectroscopy, the rest being fourfold (Si-C₄). To accomplish controlled electron-beam manipulation, the samples were carefully examined to identify near-armchair tubes (due to the sample chirality distribution and to allow atomic resolution imaging) with Si impurities. When a suitable C-Si₃ site was identified, the ≈1 Å sized beam was positioned for a fixed period of time over a chosen carbon neighbor, and a frame was acquired after each spot irradiation, as in our recent work with graphene.

The experiments were performed using two primary beam energies, 55 and 60 keV; at 55 keV, a spot irradiation time of 10 s was used whereas at 60 keV the time was reduced to 7 s. Figure 1a–c summarizes one Si atom manipulation sequence in a (20,20) armchair nanotube using focused 60 keV electron irradiation (selected frames). The intermediate positions are marked with I–V separately highlighted in Figure 1b. Another experiment consisted of a series of repeated back-and-forth jumps along the armchair direction perpendicular to the axis of a large-diameter near-armchair tube. Figure 1d shows the path of the atom on what is likely a (22,18) SWCNT with a diameter of ≈2.67 nm (see the Experimental Section), moving repeatedly between the two sublattices in a fully controlled manner. We emphasize that due to the small diffusion barrier of Si adatoms, any impurities that we can image must necessarily be bound within the lattice.

Jumps were the predominant dynamic in SWCNTs larger than 2 nm in diameter, but four other kinds of electron beam–induced processes were observed primarily in smaller diameter tubes. The first, ejection of a C neighbor resulting in a three-to-fourfold conversion is shown in Figure 2a,b, with close-ups of the local bonding shown in Figure 2c,d. Although the contrast is somewhat unclear, line profiles plotted in Figure 2e show a change in the relative position of the Si site and the disappearance of the contrast of the C neighbor. Second, we observed the removal of Si atoms during manipulation, which occurs rarely if ever in graphene, being either replaced by a C atom (Figure 2f,g) or leaving behind a monovacancy (Figure 2j,k). Interestingly, in rare cases this monovacancy remained stable long enough (>4 s) to acquire an image frame. Such vacancies have been reported in graphene, but are expected to be even more beam-sensitive in SWCNTs and to our knowledge have not been directly observed. Another peculiar case was observed when trying to move one of two Si atoms bonded within the same hexagon (Figure 2h,i): both were replaced by C between the two acquired frames. Finally, we sometimes observed Stone-Wales defects at the Si sites such as the one in Figure 2l,m.

Figure 1. Electron-beam manipulation of Si impurities in SWCNTs. a–c) Si atom moved along the zigzag direction of a (20,20) armchair nanotube using focused 60 keV electron irradiation (selected frames). The intermediate positions are marked with I–V. d) A controlled back-and-forth movement of a Si atom in a (22,18) nanotube at 55 keV (selected frames from a longer series). (See also the source data.)
To evaluate the probability of triggering jumps, we calculated the distribution of electron irradiation doses per event (taking into account that for our expected probe shape, only 26% of the beam current impinges on the target atom)\(^{[21,31]}\) and estimated the underlying Poisson expectation values by the geometric mean doses.\(^{[19]}\) The dose (geometric mean ± standard error) required to trigger a jump was \((2.1 ± 0.1) \times 10^9\) e\(^{-}\) at 55 keV \((N = 40\) jump events\) and \((6.1 ± 0.3) \times 10^8\) e\(^{-}\) at 60 keV \((N = 60)\). These result in cross sections of 0.12 barn at 55 keV and 0.43 barn at 60 keV, increasing with increasing electron energy as expected for knock-on displacements, but slightly higher than the values measured for graphene \((0.03\) barn at 55 keV and 0.29 barn at 60 keV)\(^{[21]}\) possibly reflecting the curved geometry of even large-diameter SWCNTs. For reasons that will become apparent below, only about half of the 12 separate Si impurities that we attempted to manipulate could in practice be moved.

To understand the details of the electron beam–induced dynamics, we used DFT/MD simulations,\(^{[29]}\) here using the revPBE functional,\(^{[32]}\) to study three- and fourfold coordinated Si substitutions in multiple single-walled carbon nanotube models. To account for diameter- and chirality-dependent effects, we considered three armchair (with chiral indices \((7,7),\) \((11,11),\) and \((15,15))\) and three zigzag (with indices \((12,0),\) \((20,0),\) and \((26,0))\) tubes, having diameters of \(≈10,\) 15.5, and 21 Å (and additionally the 25 Å diameter \((32,0))\) zigzag for energetics). The Si jumps were modeled by running a large number of molecular dynamics simulations in which a single carbon neighbor was provided with an initial momentum \((\vec{P})\) along the direction of the electron beam (denoted with e\(^{-}\) in Figure 3a).

In graphene, a Si substitution buckles about 0.95 Å above the lattice plane due to its larger covalent radius.\(^{[7,8,19]}\) In a cylindrical carbon nanotube, the silicon atom could in principle protrude either toward or away from the tube axis, as shown in Figure 3a. Our computations, however, show that the inside configuration is energetically unstable in tubes smaller than \(≈2\) nm in diameter in which the atom (when purposely placed inside) gets pushed through the lattice during geometry optimization. In over 2 nm tubes, represented by \((26,0)\) and \((32,0))\) chiralities in our simulations, the inside configuration becomes metastable with respective transition barriers of 0.19 and 0.38 eV (estimated from single-point energy simulations of 11 images interpolated along the transition path). These transitions, leading to a stable outside configuration, can be thermally activated with respective energy gains of 1.32 and 1.13 eV. We can therefore be confident that all Si atoms in our experiments were positioned on the outside side of the nanotube wall.

Successful bond inversions in the MD simulations were only achieved for Si atoms positioned on the “backside” of the tube facing away from the electron beam source. The position of forward-facing atoms remains unchanged even when the amount of the energy transferred to a C neighbor is as high as 17 eV. Although the two configurations cannot be distinguished in projected STEM images, this explains why roughly half of the Si atoms failed to move in our experiments.


Figure 2. Electron-beam induced dynamics. a,b) Three-to-fourfold conversion of a Si site, with closeups shown in (c) and (d) and line profiles in (e). f,g) A single or h,i) two Si atoms being replaced during manipulation by C. j,k) An ejection of Si leaving behind a monovacancy. l,m) Si within a Stone-Wales defect. (See also the source data.)
The local configuration of Si bonds in different directions, as does also the orientation of the atomic configurations. Angles 0° and 60° represent the values for graphene. (See also the source data.) The horizontal lines represent the values for graphene. Further, the energies calculated for armchair nanotubes, corresponding to angles 30° and 90°, hardly depend on diameter. This suggests that the angle that the Si–C bond forms with respect to the axis is more important than the nanotube diameter, at least for tubes larger than 10 Å. The most persistent difference from the graphene values is observed for atoms along the tube axis (angles 0° and 30°), which may be due to a weaker restoring force by their C neighbors. The additional divergence of the values for the smallest zigzag (12,0) tube reflects the strong C–C bond strain along its circumference.

Our simulations for even the largest diameter nanotube models show marked anisotropy in the threshold energy values. Moving the Si atom along the axis of either zigzag or armchair tubes requires about 1 eV less energy than in the direction perpendicular to it, which should result in large differences in the observed jump rate at a fixed beam current. However, the experimentally estimated cross sections in the two directions in larger diameter armchair tubes are practically the same within our statistics. One notable disparity with the experiment may be the role of rotation: in the simulations, the impurity site is always perfectly aligned with respect to the beam direction. However, studying this effect systematically is not currently feasible at the required level of theory.

While the observed bond inversion process in SWCNTs is fundamentally similar to graphene, we did notice some minor differences. Figure 4a shows the Si–C bond inversion along the (12,0) zigzag tube axis. In such cases, the C neighbors of the impacted atom are symmetric with respect to the inverted Si–C bond and the tube circumference, and thus the trajectory closely resembles that in graphene. This is however not the case for the bond inversion at sites located at 30° and 60° angles, where the symmetry of the neighbors breaks down, resulting in a curved trajectory in which the C atom does not directly cross over the Si but appears to traverse “around” it, resembling the mechanism of the Stone-Wales transformation in graphene. An example of a 30° case is presented in Figure 4b, depicting a bond inversion in a (7,7) zigzag tube with an initial C atom kinetic energy of 14 eV.

The curved trajectories, in turn, may result in an incomplete reconstruction and appearance of defective structures. For example, at energies lower than those required for bond inversion, the C neighbor sometimes ends up as an adatom bound either on a Si–C or C–C bridge near the site of the electron impact, resulting in a fourfold-coordinated Si. In our simulations, the thresholds for such structures to emerge in...
zigzag nanotubes were 13.4–13.7 eV and in armchair tubes 11.0–11.9 eV, the process in smaller tubes requiring less energy. The recombination of the fourfold coordinated Si with the C adatom results in a significant increase of energy similar to graphene,\(^{19}\) and therefore we assume that these structures are metastable and will eventually reconstruct into Si\(_3\). Due to computational constraints, however, it was not possible to simulate the dynamics long enough to observe this process directly, except for several cases in the (15,15) tube where the recombination did indeed occur during the MD simulations. We also note that for curved trajectories, we observed several cases of Stone-Wales transformations at the Si site within the energy ranges that would otherwise correspond to bond inversions.\(^{21,33}\)

3. Conclusions

In summary, we have demonstrated via atomically resolved scanning transmission electron microscopy experiments that silicon impurities in single-walled carbon nanotubes can be manipulated with focused electron irradiation. The curved geometry of the tubes affects the threshold energies as predicted by density functional theory molecular dynamics simulations. The orientation of the silicon site with respect to the beam direction plays an important role: only impurities along the axis can be easily visualized, and only those incorporated into the wall facing away from the beam can be moved. Further, the computations predict an asymmetry in the armchair and zigzag directions for smaller diameter tubes, although in our experiments with large diameter tubes we did not observe this. Our results expand the range of strongly bound materials where impurities can be manipulated with a focused electron beam beyond two dimensions,\(^{34,35}\) further underscoring the potential of scanning transmission electron microscopy as a tool for atomically precise manipulation. Controllable modification of the quasi-1D electronic structure of single-walled carbon nanotubes may enable devices such as tunable single-molecule Fabry-Pérot interferometers and other electron wave resonators.\(^{36}\)

4. Experimental Section

**Sample Preparation:** The single-walled carbon nanotubes were synthesized in a vertical floating catalyst reactor using ethanol (\(\text{C}_2\text{H}_5\text{OH}\)) as the primary carbon source and hydrogen (\(\text{H}_2\)) as a reaction mediator.\(^{24,25}\) Ferrocene and thiophene were used as a catalyst source and growth promoter, respectively. The synthesis conditions were chosen to favor tubes with high helicities and large diameters, feeding 300 cm\(^3\) min\(^{-1}\) of \(\text{H}_2\) and 300 cm\(^3\) min\(^{-1}\) of nitrogen carrying \(\text{C}_2\text{H}_5\text{OH}\) at the rate of 4 \(\mu\text{L}\) min\(^{-1}\). The material was deposited by placing a perforated silicon nitride membrane acquired from Ted Pella Inc. on a membrane filter, through which the reactor exhaust was passed for 60–120 s, accumulating nanotube networks suitable for high-resolution electron microscopy.

The Si substitution was carried out in a custom-made plasma chamber connected to the electron microscope through an ultrahigh vacuum transfer system.\(^{19}\) \(\text{Ar}^+\) ions, formed in a microwave plasma cavity at the pressure of \(\approx 5 \times 10^{-6}\) mbar, were accelerated to a kinetic energy of \(\approx 50\) eV to create intermittent vacancies in the tube walls.\(^{19}\) The total radiant exposure was \(\approx 1\) ion nm\(^{-2}\). Concurrently, the samples were irradiated with a high-power laser similar to the one which...
was previously used for cleaning 2D materials,[37] which in this case thermally mobilized Si impurity atoms from the mostly carbon-based contamination to fill the created vacancies. After plasma irradiation, the samples were transferred directly to the electron microscope in ultrahigh vacuum without exposing them to the ambient atmosphere.

**Transmission Electron Microscopy:** All experiments were conducted using the aberration-corrected Nion UltraSTEM100 scanning transmission electron microscope in Vienna, operated at two electron energies, 55 and 60 keV, in ultrahigh vacuum (10^{-10} mbar). The typical beam current of the instrument was close to 35 pA. The beam convergence semiangle was 30 mrad and all images were acquired with the medium angle annular dark field (MAADF) detector with a semiangular range of 60–200 mrad. Electron energy loss spectroscopy was used to identify the Si impurities (for details, see ref. [9]). To remove the influence of probe tails, some images were processed using a double Gaussian filtering procedure,[38] and colored with the ImageJ lookup table “fire” to enhance contrast.

To estimate the chiral indices of the SWCNTs, the Fourier transform of the image was used to measure the angle between the upper and lower walls that corresponds to twice the chiral angle and this was combined with an estimation of the diameter from the real-space image.

**Density Functional Theory:** All simulations were performed using density functional theory (DFT) as implemented in the GPAW package.[39] The revised PBE exchange-correlation functional,[32] a localized (dzp) basis set,[40] a grid spacing of 0.2 Å, and three k-points in the periodic axial direction were used. The lengths of the armchair and zigzag SWCNTs were 12.35 and 12.83 Å, respectively. The supercell size in the directions perpendicular to the tube axis was set to 38 Å, which gave more than 10 Å separation between the periodic replicas even for the largest considered (32,0) SWCNT with a diameter of 25.4 Å.

The displacement threshold energies were calculated using Velocity-Verlet molecular dynamics with a time step of 0.5 fs and varying the amount of the energy transferred to a C atom at 0.1 eV intervals.[41]

A detailed description of the methodology can be found in ref. [29]. A longer time step was used here (0.5 fs instead of 0.1 fs) to facilitate the large number of required simulations as well as the larger nanotube models with up to 312 atoms. The threshold energy for pristine graphene was about 3% greater than reported earlier,[29] and test simulations for the (7,7) tube with respect to the time step, tube length, and k-points showed that the presented values of the threshold energies were converged to within 0.3 eV.

**Supporting Information**

The open data files are available on the Phaidra repository with the identifier https://doi.org/11335/10.94951S. The data include unprocessed STEM/MAADF image stacks of the manipulation sequences of Figure 1 and the dynamical transformations of Figure 2, as well as selected simulation trajectory files underlying Figure 3 and Figure 4.

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**Conflict of Interest**

The authors declare no conflict of interest.

**Keywords**

atom manipulation, heteroatoms, nanotechnology, STEM

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